

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: PATEL, et al.

Attorney Docket No.: P19-US

Serial No.: -- 10/005,308

Group Art Unit: 2812

Filed: --

December 03, 2001

Examiner: -- Unknown

For:

A METHOD FOR FORMING A MICRO-ELECTROMECHANICAL DEVICE

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Assistant Commissioner of Patents Washington, D.C. 20231

February 14, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO/SSSB/08A. Copies of the cited references are enclosed.

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits and (2) expiration of the three month period following filing of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

The Patent Office is authorized to charge our Deposit Account No. 501516 for

any fee which it deems to be required to effect consideration of this statement.

Respectfully submitted,

Gregory R. Muir

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control number C mplet if Known Substitute for form 1449A/PTO 10/005,308 **Application Number** INFORMATION DISCLOSURE December 3, 2001 Filing Date STATEMENT BY APPLICANT First Named Inventor PATEL et al. 2812 Art Unit (use as many sheets as necessary) Examiner Name P19-US Attorney Docket Number Sheet of

			U.S. PAT	ENT DOCUMENTS	
Examiner	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant
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Examiner	Cite	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages		
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			AL AGUIDE	Application Number	10/005,308	
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Sheet	2	of	2	Attorney Docket Number	P19-US	

Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	י
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